


Form PTO-1449 (REV. 8-83)		US Dept. of Commerce PATENT & TRADEMARK OFFICE		ATTY DOCKET NO. DA1063D		APPLICATION NO. New U.S. Patent Application	
INFORMATION DISCLOSURE STATEMENT (Use several sheets if necessary)				APPLICANT(S) Joel A. KUBBY, Pinyen LIN, Jingkuang CHEN, Yi SU			
				FILING DATE			
U.S. PATENT DOCUMENTS							
EXAMINER INITIAL		DOCUMENT NUMBER	DATE	NAME	CLASS	SUB CLASS	
KSW		5,612,815	03/18/1997	Labeye et al.			
KSW		5,002,350	03/26/1991	Dragone			
KSW		5,002,354	03/26/1991	Koai			
KSW		5,261,015	11/09/1993	Glasheen			
FOREIGN PATENT DOCUMENTS							
		DOCUMENT NUMBER	DATE	COUNTRY	CLASS	SUB CLASS	
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KSW		Cornel Marxer et al., "Micro-Opto-Mechanical 2 X 2 Switch for Single-Mode Fibers Based on Plasma-Etched Silicon Mirror and Electrostatic Actuation", Journal of Lightwave Technology, Vol. 17, No. 1, January 1999					
KSW		Shi-Sheng Lee et al., "Free-Space Fiber-Optic Switches Based on MEMS Vertical Torsion Mirrors", Journal of Lightwave Technology, Vol. 17, No. 1, January 1999					
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KSW		E. Ollier et al., "Micro-opto mechanical switch integrated on silicon", Electronics Letters, Vol. 31, No. 23, November 1995					
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KSW		"Arrayed Waveguide Grating Multiplexer/Demultiplexer", Lucent Technologies, January 2000					
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						4/3/04	
Examiner: Initial if citation considered, whether or not citation is in conformance with M.P.E.P. 609; draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.							

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INFORMATION DISCLOSURE STATEMENT (Use several sheets if necessary)		APPLICANT Joel A. Kubby et al.	
		FILING DATE	GROUP ART UNIT

U.S. PATENT DOCUMENTS

EXAMINER INITIAL	DOCUMENT NUMBER	PUBLICATION DATE	NAME OF PATENTEE	CLASS	SUB CLASS
KSW	5,999,290	12/7/99	Li	359	127
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OTHER DOCUMENTS (Including Author (in CAPS), Title, Publication Date, Pages, etc.)

EXAMINER

Kimi S. Wood

DATE CONSIDERED

4/3/04

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